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IBM Docket No. BUR920000141US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Nicole S. Carpenter et al.**

Serial No.: **09/892,954**

Date: **February 25, 2004**

Filed: **June 27, 2001**

Group Art Unit: **1746**

Title: **CLEANING OF SEMICONDUCTOR
WAFERS BY CONTAMINATE
ENCAPSULATION**

Examiner: **Gentle E. Winter**

DeLIO & PETERSON, LLC
121 Whitney Avenue
New Haven, CT 06510-1241

LETTER TO OFFICIAL DRAFTSMAN

Mail Stop ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Dear Sir:

Applicants are herewith submitting 3 sheets of Formal Drawings for the approval of the Draftsman.

Please charge the Assignee IBM Corporation Deposit Account No. **09-0456** for any fee related to the acceptance of the attached Formal Drawings. A duplicate copy of this letter is enclosed for that purpose.

Respectfully submitted,

BY:


Attorney: **John J. Tomaszewski**
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